

Serial No. 09/935,699
Docket No. T36-135964M/RS

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Uemura et al.

Serial No.: 09/935,699

Group Art Unit: 1733

Filed: August 24, 2001

Examiner: Kornakov, Michail

For: METHOD FOR MANUFACTURING A GROUP III NITRIDE COMPOUND
SEMICONDUCTOR DEVICE

Honorable Commissioner of Patents
Alexandria, VA 22313-1450
Box AF

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RESPONSE AND
REQUEST FOR RECONSIDERATION

Do not enter
M.K. 12/01/05

Sir:

In response to the Office Action dated August 23, 2005, Applicant states as follows:

REMARKS

Claims 21-24 and 31-38 are all the claims presently pending in the application.

Claims 21-23, 32 and 34-38 stand rejected under 35 U.S.C. § 102(b) as allegedly being anticipated by Maniar et al. (U. S. Patent No. 5,525,542). Claim 31 stands rejected under 35 U.S.C. § 102(b) or alternatively under 35 U.S.C. § 103(a) as allegedly being unpatentable over Maniar. Claim 33 stands rejected under 35 U.S.C. § 103(a) as allegedly being unpatentable over Maniar.

These rejections are respectfully traversed in view of the following discussion.

I. THE CLAIMED INVENTION

The claimed invention, as recited in claim 21, is directed to a method for manufacturing a group III nitride compound semiconductor device, including irradiating a